

Form PTO-1449
(Rev. 8-83)U.S. Department of Commerce
Patent and Trademark Office

Atty Docket 0756-1936

Serial No. 09/255,777

INFORMATION DISCLOSURE STATEMENT

Applicants: Shunpei YAMAZAKI et al.

Filing Date: February 23, 1999

Group Art Unit: 2812

U.S. PATENT DOCUMENTS

Examiner Initial	Document Number	Date	Name	Class	Subclass	Filing Date (if appropriate)
RB	2001/0050664	12/13/2001	Yamazaki et al.			
	4,468,855	09/04/1984	Sasaki			
	4,651,182	03/17/1987	Yamazaki			
	4,762,807	08/09/1988	Yamazaki			
	4,826,711	05/02/1989	Yamazaki et al.			
	5,313,077	05/17/1994	Yamazaki			
	5,315,132	05/24/1994	Yamazaki			
	5,409,982	04/25/1995	Imura et al.			
	5,514,879	05/07/1996	Yamazaki			
	5,536,575	07/16/1996	Imura et al.			
	5,543,636	08/06/1996	Yamazaki			
	5,569,490	10/29/1996	Imura et al.			
	5,614,732	03/25/1997	Yamazaki			
	5,652,016	07/29/1997	Imura et al.			
	5,859,445	01/12/1999	Yamazaki			
RB	6,011,277	01/04/2000	Yamazaki			
	6,221,701	04/24/2001	Yamazaki			

FOREIGN PATENT DOCUMENTS

Examiner Initial	Document Number	Date	Country	Class	Subclass	Translation	
						Yes	No
RB	0 072 216	02/16/1983	EP			Full Eng	
	0 486 284	05/20/1992	EP			Full Eng	
	02-153896	06/13/1990	JP			Eng Abst	
	03-022540	01/30/1991	JP			Full Eng	
	04-085922	03/18/1992	JP			Eng Abst	
	04-133029	05/07/1992	JP			Eng Abst	
	04-186775	07/03/1992	JP			Eng Abst	
	04-190329	07/08/1992	JP			Eng Abst	
	58-023479	02/12/1983	JP			Eng Abst	
	58-071663	04/28/1983	JP			Eng Abst	

Examiner

Date Considered

MINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if performance and not considered. Include copy of this form with next communication to applicant.

Form PTO-1449
(Rev. 8-83)

U.S. Department of Commerce
Patent and Trademark Office

Atty Docket 0756-1936

Serial No. 09/255,777

INFORMATION DISCLOSURE STATEMENT

Applicants: Shunpei YAMAZAKI et al.

Filing Date: February 23, 1999

Group Art Unit: 2812

U.S. PATENT DOCUMENTS

Examiner Initial	Document Number	Date	Name	Class	Subclass	Filing Date (if appropriate)
103	5,254,208	10/19/1993	Zhang	11	01	
103	5,716,857	02/10/1998	Zhang	11	01	
103	6,008,078	12/28/1999	Zhang	11	01	

FOREIGN PATENT DOCUMENTS

Examiner Initial	Document Number	Date	Country	Class	Subclass	Translation Yes No
103	02-210832	08/22/1990	JP	11	01	Eng Abst
	04-080914	03/13/1992	JP	11	01	Eng Abst
	04-093080	03/25/1992	JP	11	01	Eng Abst
	05-121733	05/18/1993	JP	11	01	Eng Abst
	57-170571	10/20/1982	JP	11	01	Eng Abst
	62-052968	03/07/1987	JP	11	01	Eng Abst
	62-298151	12/25/1987	JP	11	01	Full Eng
103	63-142807	06/15/1988	JP	11	01	Full Eng

RECEIVED
MAR - 4 2002
TC 2800 MAIL ROOM

Examiner

Date Considered

*EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

Atty Docket 0756-1936

Serial No. 09/255,777

INFORMATION DISCLOSURE STATEMENT

APR 22 2002

Filing Date: February 23, 1999

Group Art Unit: 2812

FOREIGN PATENT DOCUMENTS

Examiner Initial	Document Number	Date	Country	Class	Subclass	Translation Yes No
113	58-118154	07/14/1983	JP	I	I	Full Eng
	60-186066	09/21/1985	JP			Eng Abst
	60-245173	12/04/1985	JP			Full Eng
	62-007691	01/14/1987	JP			Eng Abst
	62-054422	03/10/1987	JP			Eng Abst
	62-104021	05/14/1987	JP			Eng Abst
113	63-056912	03/11/1988	JP	I	I	Eng Abst

OTHER DOCUMENT

(Including Author, Title, Date, Pertinent Pages, Etc.)

Examiner Initial

Hanada et al., "Preparation and Physical Properties of rf-Sputtered Amorphous Films in the Al O -AlN System", pp. 227-235, 1991, Journal of Non-Crystalline Solids, Vol. 135

RECEIVED
APR 24 2002
TECHNOLOGY CENTER 2800